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PATENT



IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE

Applicant:	Dong Joon Kim)	I hereby certify that this paper is being
Serial No.:	10/636,168)	deposited with the United States Postal
Filed:	August 7, 2003)	Service with sufficient postage as first
Title:	METHOD OF FORMING METAL)	class mail in an envelope addressed to
	LINE IN SEMICONDUCTOR)	Mail Stop Amendment, Commissioner for
	DEVICE)	Patents, P.O. Box 1450, Alexandria,
)	Virginia 22313-1450, on July 27, 2004 .
Group Art Unit:	2818)	
Examiner:	David Nhu)	
Attorney Docket No.:	29936/39478)	


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AMENDMENT "A" AND
RESPONSE TO OFFICIAL ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the non-final official action dated April 29, 2004, please amend the above-identified patent application as set forth herein.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.